## Notice of References Cited Application/Control No. 10/603,980 Examiner Tianjie Chen Applicant(s)/Patent Under Reexamination DAGUE ET AL. Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2002/0167763	11-2002	Macpherson et al.	360/265.8
	В	US-6,661,615	12-2003	Tsuda, Shingo	360/265.7
	С	US-2001/0015875	08-2001	Ohta et al.	360/254.8
	D	US-6,538,853	03-2003	Williams et al.	360/265.9
	Е	US-		·	
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US	, -		
	М	US-			· ·

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Z					
	0					
	Ρ					
	Q	·		-		
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)							
	U								
	V								
	w								
	x								

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.